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CONFIRMATION NO. 4558

SERIAL NUMBER 10/537,529	FILING OR 371(c) DATE 06/03/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 4887/PCT
APPLICANTS Makoto Otsuki, Itami-shi, JAPAN; Masayuki Nishikawa, Itami-shi, JAPAN; Yasuyuki Matsui, Itami-shi, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/08108 06/10/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-176746 06/20/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 40
INDEPENDENT CLAIMS 2				
ADDRESS 21553				
TITLE Method of producing semiconductor single crystal wafer and laser processing device used therefor				
FILING FEE RECEIVED 1900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	